

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF:

Jaehwan EUN, et al.

CONFIRMATION NO.: 1951

FILED: June 17, 2005

GROUP ART UNIT:

SERIAL NO. 10/539,886

EXAMINER: Mazumdar, Sonya

FOR: Method For Preparing Film Structure Comprising
Ferroelectric Single Crystal Layer

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

This is in response to the outstanding Office Communication dated September 14, 2007. The Commissioner is authorized to charge any required fees in the prosecution of this application to Deposit Account No. 503814.

Please amend the present application as follows: